IAP15 Rec'd PCT/PTO 18 OCT 2006

application of

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Seiji AKITA et al.

Serial No. 10/576,476

Filed April 20, 2006

NANOSIZE HEATER-MOUNTED NOZZLE AND METHOD FOR MANUFACTURING SAME AND METHOD FOR FORMING MICRO THIN FILM

[Corresponding to PCT/JP2004/015598 Filed October 21, 2004]

Mail Stop: MISSING PARTS

Attorney Docket No. 2006 0598A

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

### PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$130.00 to cover Patent Office fees relating to filing the following attached papers:

Late filing of executed Declaration ......\$130.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

10/23/2006 ATRAN1

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Respectfully submitted,

Seiji AKITA et al.

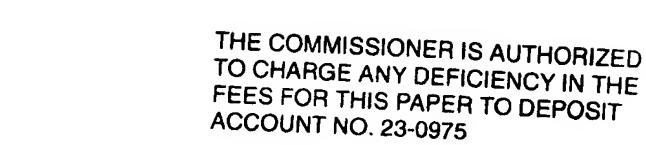
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2006 0598A





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Seiji AKITA et al. : Mail Stop: MISSING PARTS

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### SUBMISSION OF EXECUTED DECLARATION UNDER 35 USC 371

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Submitted herewith is a Declaration for the above application executed by the inventors.

Also enclosed are the PTO surcharge of \$130.00 required by 37 CFR 1.492(e).

It is respectfully submitted that the application is now complete, and early indication thereof is now requested.

Respectfully submitted,

Seiji AKITA et al.

By Charles R. Watts

Registration No. 33,142

Attorney for Applicants

CRW/asd Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 October 18, 2006

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**ACCOUNT NO. 23-0975** 

NANOSIZE HEATER-MOUNTED NOZZLE AND METHOD FOR MANUFACTURING SAME AND METHOD FOR FORMING MICRO THIN FILM [Corresponding to PCT/JP2004/015598 Filed October 21, 2004]

# SUBMISSION OF ENGLISH VERSIONS OF INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY AND WRITTEN OPINION OF THE **INTERNATIONAL SEARCHING AUTHORITY**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith for consideration by the Examiner are:

- An English version of the International Preliminary Report on Patentability; and 1)
- 2) An English version of the Written Opinion of the International Searching

Authority.

Respectfully submitted,

Seiji AKITA et al.

Charles R. Watts

Registration No. 33,142 Attorney for Applicants

ĆRW/asd Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 October 18, 2006